

Tandem Accelerator

Irradiations and surface analysis:

University of Michigan (internal – short code):	\$30/h/sample
Setup fee/ion/energy	\$30
Other Universities	\$60/h/sample
Setup fee/ion/energy	\$60
Business rates:	\$200/h/sample
Setup fee/ion/energy	\$200

Ion Implanter:

University of Michigan (internal – short code):	\$30/h/sample
Setup fee/ion/energy	\$30
Other Universities	\$60/h/sample
Setup fee/ion/energy	\$60
Business rates:	\$200/h/sample
Setup fee/ion/energy	\$200

Ion Beam Assisted Deposition System:

University fees:	\$60 first sample
Each additional sample:	\$30
Setup fee/ion/energy	\$60
Business rates:	\$100 /h/sample
Each additional sample:	\$50
Setup fee/ion/energy	\$100

Vacuum furnace:

University fees:	\$50/sample/calendar day
Setup fee	\$50
Business rates:	\$100/h/sample
Setup fee	\$100

Dektak profilometer.

University fees:	\$30/half day (4 h)
Business rates:	\$60/half day (4 h)

Hardness Indenter:

University fees:	\$30/half day (4 h)
Business rates:	\$60/half day (4 h)

Residual Stress Measurement System

University fees:	\$30/half day (4 h)
Business rates:	\$60/half day (4 h)